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**\*BIBDATASHEET\***

Bib Data Sheet

**CONFIRMATION NO. 4146**

SERIAL NUMBER 09/920,341	FILING DATE 08/01/2001 RULE	CLASS 356	GROUP ART UNIT 2877	ATTORNEY DOCKET NO. 5119-08301
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**APPLICANTS**

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*Yes SN*
**\*\* CONTINUING DATA** \*\*\*\*

This appln claims benefit of 60/222,233 08/01/2000

*None SN*
**\*\* FOREIGN APPLICATIONS** \*\*\*\*

**IF REQUIRED, FOREIGN FILING LICENSE GRANTED**

\*\* 10/15/2001

**\*\* SMALL ENTITY \*\***

Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	TX	DRAWING 52	CLAIMS 38/49	CLAIMS 4/3
Verified and Acknowledged Examiner's Signature	<i>Sanjiv</i>	Initials			

**ADDRESS**

 Molecular Imprints, Inc.  
 Legal Department  
 P.O. Box 81536  
 Austin, TX  
 78708-1536

**TITLE**

Methods for high-precision gap and orientation sensing between a transparent template and substrate for imprint lithography

<input type="checkbox"/> All Fees
<input type="checkbox"/> 1.16 Fees ( Filing )
FILING FEE FEES: Authority has been given in Paper